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| Search Notes  | Application/Control No. 10659272 | Applicant(s)/Patent Under Reexamination SAITO ET AL. |
| | Examiner Pickard, Alison K | Art Unit 3676 |

| SEARCHED | | | |
|----------|----------------------------|--------|----------|
| Class | Subclass | Date | Examiner |
| 277 | 592, 628, 650, 652 updated | 1-3-08 | ap |

| SEARCH NOTES | | |
|---|--------|----------|
| Search Notes | Date | Examiner |
| see east attached | 1-3-08 | ap |
| interference terms: (film and Silic\$3 and reaction and fluoro\$6).clm. | 1-3-08 | ap |

| INTERFERENCE SEARCH | | | |
|---------------------|-----------|--------|----------|
| Class | Subclass | Date | Examiner |
| all subs | see notes | 1-3-08 | ap |